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## **BIB DATA SHEET**

## **CONFIRMATION NO. 6885**

RULE  APPLICANTS Yoshinori Iwanaga, Kumamoto-shi, JAPAN; ** CONTINUING DATA ******** This application is a 371 of PCT/JP04/16177 10/25/2004 ** FOREIGN APPLICATIONS ************************************	SERIAL NUM		FILING OF DAT		,					ATTORNEY DOCKET NO.		
APPLICANTS Yoshinori Iwanaga, Kumamoto-shi, JAPAN; **CONTINUING DATA **********************************	10/577,91	5	05/01/2	006		430		1795		Q94742		
Yoshinori Iwanaga, Kumamoto-shi, JAPAN;  ***CONTINUING DATA  ***This application is a 371 of PCT/IP04/16177 10/25/2004  ***FOREIGN APPLICATIONS  JAPAN 2003-370938 10/30/2003  ***IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 12/31/2006  ***Foreign Priority claimed 35U9C 119(e-i) conditions mer			RUL	E								
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